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CLAIMS

- 1. A reactor wall coating in a fluidized bed reactor, the coating having a thickness of at least $100 \mu m$ and a molecular weight distribution comprising a major peak having:
 - (a) an Mw/Mn ratio of less than 10;
 - (b) an Mz/Mw ratio of less than 7, and
 - (c) a maximum value of d(wt%)/d(log MW) at less than 25,000 daltons in a plot of d(wt%)/d(log MW), where MW is the molecular weight in daltons.
- 2. The reactor wall coating of claim 1, wherein the thickness is at least $125 \mu m$.
- 3. The reactor wall coating of claim 1, wherein the thickness is at least $150 \ \mu m$.
- 4. The reactor wall coating of claim 1, wherein the Mw/Mn ratio is less than
- 5. The reactor wall coating of claim 1, wherein the Mz/Mw ratio is less than 4.
- 6. The reactor wall coating of claim 1, wherein the maximum value of d(wt%)/d(log MW) is at less than 15,000 daltons.
- 7. The reactor wall coating of claim 1, wherein the maximum value of d(wt%)/d(log MW) is at less than 13,000 daltons.
- 8. The reactor wall coating of claim 1, wherein the major peak has an Mn value of less than 7000.

- 9. The reactor wall coating of claim 1, wherein the coating has an initial voltage potential V_0 of at least 400 V, where V_0 is the absolute value of the voltage potential measured immediately after application of a charging voltage potential of 9 kV for a period of 20 ms.
- 10. The reactor wall coating of claim 9, wherein V_0 is at least 600 V.
- 11. The reactor wall coating of claim 9, wherein V_0 is at least 800 V.
- 12. The reactor wall coating of claim 9, wherein V_0 is at least 1000 V.
- 13. The reactor wall coating of claim 9, wherein the coating has a voltage retention value V_{60} of at least 0.8 V_0 , where V_{60} is the absolute value of the voltage potential measured 60 s after application of the charging voltage potential.
- 14. The reactor wall coating of claim 13, wherein V_{60} is at least $0.9V_0$.
- 15. The reactor wall coating of claim 9, wherein the coating has a voltage retention value V_{120} of at least $0.75V_0$, where V_{120} is the absolute value of the voltage potential measured 120 s after application of the charging voltage potential.
- 16. The reactor wall coating of claim 15, wherein V_{120} is at least $0.8V_0$.
- 17. The reactor wall coating of claim 15, wherein V_{120} is at least $0.9V_0$.
- 18. The reactor wall coating of claim 9, wherein the coating has a voltage retention value V_{300} of at least $0.75V_0$, where V_{300} is the absolute value of the voltage potential measured 300 s after application of the charging voltage potential.
- 19. The reactor wall coating of claim 18, wherein V_{300} is at least $0.8V_0$.

- 20. The reactor wall coating of claim 1, wherein the major peak contains at least 50 wt% of the total weight of the molecular weight distribution.
- 21. The reactor wall coating of claim 1, wherein the major peak contains at least 60 wt% of the total weight of the molecular weight distribution.
- 22. The reactor wall coating of claim 1, wherein the major peak contains at least 70 wt% of the total weight of the molecular weight distribution.
- 23. A process for forming a coating on a reactor wall in a fluidized bed reactor, the process comprising polymerizing olefin monomer in the reactor in the presence of bimetallic catalyst and an aluminum alkyl cocatalyst to form a reactor wall coating having a thickness of at least $100 \, \mu m$, wherein the bimetallic catalyst comprises a non-metallocene transition metal compound and a metallocene compound on an inorganic oxide support.
- 24. The process of claim 23, wherein the olefin monomer comprises ethylene.
- 25. The process of claim 23, wherein the olefin monomer comprises ethylene and comonomer selected from propylene, C₄-C₂₀ alpha olefins, and mixtures thereof.
- 26. The process of claim 23, wherein the aluminum alkyl cocatalyst comprises trimethylaluminum.
- 27. The process of claim 23, wherein the non-metallocene transition metal compound is selected from titanium halides, titanium oxyhalides, titanium alkoxyhalides, vanadium halides, vanadium oxyhalides, vanadium alkoxyhalides, and mixtures thereof.

- 28. The process of claim 23, wherein the metallocene compound is a substituted, unbridged bis-cyclopentadienyl compound.
- 29. The process of claim 23, wherein the inorganic oxide support comprises silica.
- 30. The process of claim 23, wherein the process is effective to form a reactor wall coating at a rate of at least 20 μ m/day, averaged over a period of 5 days.
- 31. The process of claim 23, wherein the process is effective to form a reactor wall coating at a rate of at least 25 μ m/day, averaged over a period of 5 days.
- 32. The process of claim 23, wherein the process is effective to form a reactor wall coating at a rate of at least 30 μ m/day, averaged over a period of 5 days.
- 33. The process of claim 23, wherein the reactor wall coating has a thickness of at least 125 μm .
- 34. The process of claim 23, wherein the reactor wall coating has a thickness of at least 150 μm .
- 35. A process for forming a coating in situ on a reactor wall of a fluidized bed reactor during polymerization, the process comprising:
 - (a) providing a fluidized bed reactor comprising a reaction vessel having an interior reactor wall;
 - (b) polymerizing olefin monomer in the reactor in the presence of bimetallic catalyst and an aluminum alkyl cocatalyst to form a reactor wall coating on the interior reactor wall, the coating having a thickness of at least $100 \, \mu m$, wherein the bimetallic catalyst comprises a non-metallocene transition metal compound and a metallocene compound on an inorganic oxide support; and
 - (c) recovering polymerized olefin.

- 36. The process of claim 35, wherein prior to the step of polymerizing, the interior reactor wall is provided essentially free of reactor wall coating.
- 37. The process of claim 35, wherein prior to the step of polymerizing, the interior reactor wall is provided having a reactor wall coating of less than 100 μ m.
- 38. The process of claim 35, wherein prior to the step of polymerizing, the interior reactor wall is provided having a reactor wall coating of less than 50 μm.
- 39. The process of claim 35, wherein prior to the step of polymerizing, the interior reactor wall is provided having a reactor wall coating of less than 20 μ m.
- 40. The process of claim 35, wherein prior to the step of polymerizing, the interior reactor wall is provided having a reactor wall coating of less than 10 μm.
- 41. The process of claim 35, wherein the polymerization is carried out without removing from the interior reactor wall a previously applied wall coating.

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